

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/756,793	BABICH ET AL.
	Examiner	Art Unit
	Celia Chang	1625

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
546	11, 223	8/8/2007	CC
	229, 232		
534	10, 751		